

PXY 200

compact 2-axes translation stages

Concept:

The systems of the series PXY 200 are ideally suited for nm-precise positioning of optic components such as mirrors and laser diodes, adjustment and mounting in semiconductor technologies and electronics, and applications in measurement technologies and quality assurance as well as microbiology.

The series PXY 200 consist of piezo electrical actuator in stage design with a solid top and bottom plate for easily integration in optical setups. The monolithic flexure hinges design offers high precision motion range, high stiffness and in due of this excellent dynamical performance for extremely fast and accurate positioning tasks

Specials:

With the use of a control signal, the X and Y-axis can be controlled separately. The axis are located orthogonal to each other and the direction of motion is show by small markings on the stage. As an option they may come equipped with strain gage or capacitive position sensors, depending on the system configuration, to achieve very accurate repeatability in the low nanometer range. The systems of this series are available in vacuum and cryogenic temperature configurations.

Interfaces:

The elements of the series PXY are actuators integrated with an inner lever transmission in housing. Since the lever mechanism works in both directions, pulling forces between bottom and top plate need to be avoided, as they could damage the stage. The stage is fixed to a base plate.

Components can be mounted on the top plate by two threaded diagonal holes and can be accurately affixed using the precise pin holes.



image: PXY 200

Product highlights:

- accurate parallel motion
- up to 200µm motion range
- without mechanical play
- easily combined with other piezo electrical systems
- precison pin holes for accurate adjustment
- high dynamic range

Applications:

- fiber positioning
- 2D-scanning systems
- · beam alignment
- semiconductor
- micro manipulation



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PXY 200

Technical data:

| linear positioning stage | unit | PXY 200 | PXY 200 SG |
|--|----------|--------------------------|--------------------------|
| part no. | | T-227-00 | T-227-01 |
| axis | - | X,Y | X,Y |
| motion in open(±10%)/closed loop (±0.2%)* | μm | 200/ - | 200/160 |
| capacitance per axis (±20%)** | μF | 5.2 | 5.2 |
| resolution (open/closed loop)*** | nm | 0.4/ - | 0.4/4 |
| integrated measurement system | - | - | strain gage |
| typ. repeatability | nm | - | ±5 |
| typ. non-linearity | % | - | 0.04 |
| resonant frequency x/y (unloaded) | Hz | 350/350 | 350/350 |
| max. push/pull forces | N in x | 130/13 | 130/13 |
| | N in y | 130/13 | 130/13 |
| stiffness x/y | N/µm | 0.65/0.65 | 0.65/0.65 |
| voltage range | V | -20130V | -20130V |
| connector (additional variation please see table below) **** | - | LEMO 0S.302 | LEMO 0S.302/ LEMO 0S.304 |
| cable length | m | 1 | 1.2 |
| temperature range | °C | -20°C +80°C | -20°C +80°C |
| material | - | aluminum/stainless steel | |
| dimensions (LxWxH) | mm | 70x70x25 | 70x70x25 |
| cental aperture (diameter) | mm | 28 | 28 |
| weight | g | 350 | 350 |
| t! | r.c. () | NIV 40 /2 CLE | |

^{*} typical value measured with NV 40/3 amplifier (closed loop: NV 40/3 CLE amplifier)

^{****} additional connectors configuration examples please see table blow

| Product name | Description | Specials | Part. No Suffix. |
|-------------------|---|-------------------------------|------------------|
| PXY 200 Digital | Version for digital controller series d-Drive and 30DV50 in combination with additional functionalities. | Connector Sub-D 15 | T-227-00D |
| PXY 200 SG Extern | Version with sensor pre-amplifier for the use with "CLE" amplifier units and with the additional functionalities: Interchangeability, ASI | Connector Sensor: ODU 4pin | T-227-01E |

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^{**} typical value for small electrical field strength

^{***} the resolution is only limited by the noise of the power amplifier and metrology